

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Inventor .....Nishant Sinha  
Assignee .....Micron Technology, Inc.  
**PRIORITY** Group Art Unit .....2812  
**PRIORITY** Examiner .....J. Kennedy  
Attorney's Docket No. ....MI22-2464  
Customer No. ....021567  
Title: Methods for Forming Capacitor Structures; and Methods for Removal of Organic Materials

**PRELIMINARY AMENDMENT**

To: Mail Stop Patent Application  
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**AMENDMENTS**